



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77760

OGATA, TOSHIYUKI, et al.

Appln. No.: 10/748,190

Group Art Unit: 1712

Confirmation No.: 5536

Examiner: Marc S. Zimmer

Filed: December 31, 2003

For: POSITIVE RESIST COMPOSITION AND BASE MATERIAL CARRYING LAYER OF
THE POSITIVE RESIST COMPOSITION

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of November 4, 2005, from February 4, 2006, to March 4, 2006.

A check for the statutory fee of \$120.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.


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WASHINGTON OFFICE

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CUSTOMER NUMBER

Respectfully submitted,


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120.00 OP

Date: March 1, 2006